	Application No.	Applicant(s)
	10/709,637	CHANG, TING-JUI
Notice of Allowability	Examiner	Art Unit
	Lucy P. Chien	2871
The MAILING DATE of this communication apperature of the second process of the second process of the communication apperature of the Office or upon petition by the applicant. See 37 CFR 1.313	(OR REMAINS) CLOSED in thi or other appropriate communic IGHTS. This application is subj	s application. If not included ation will be mailed in due course. THIS
1. This communication is responsive to <u>application filed on 5.</u>	<u>/19/2004</u> .	
2. The allowed claim(s) is/are <u>1-7 and 9-14</u> .		
<ul> <li>3.  Acknowledgment is made of a claim for foreign priority unerstanding a)  All b)  Some* c)  None of the:</li> <li>1.  Certified copies of the priority documents have</li> </ul>		).
Certified copies of the priority documents have     Certified copies of the priority documents have		•
Copies of the certified copies of the priority do		<del></del>
International Bureau (PCT Rule 17.2(a)).	cuments have been received in	this national stage application from the
* Certified copies not received:		
Applicant has THREE MONTHS FROM THE "MAILING DATE" noted below. Failure to timely comply will result in ABANDONN THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.		eply complying with the requirements
4. A SUBSTITUTE OATH OR DECLARATION must be subminFORMAL PATENT APPLICATION (PTO-152) which give		
5. CORRECTED DRAWINGS (as "replacement sheets") mus	st be submitted.	
(a) ☐ including changes required by the Notice of Draftspers		PTO-948) attached
1) 🔲 hereto or 2) 🔲 to Paper No./Mail Date		
(b) ☐ including changes required by the attached Examiner' Paper No./Mail Date	s Amendment / Comment or in t	he Office action of
Identifying indicia such as the application number (see 37 CFR 1 each sheet. Replacement sheet(s) should be labeled as such in t		
6. DEPOSIT OF and/or INFORMATION about the depo attached Examiner's comment regarding REQUIREMENT		
Attachment(s)  1. Notice of References Cited (PTO-892)	5 Notice of Inform	nal Patent Application
2. Notice of Draftperson's Patent Drawing Review (PTO-948)	6. ☐ Interview Sumn	
<u> </u>	Paper No./Mai	I Date
3. Information Disclosure Statements (PTO/SB/08), Paper No./Mail Date	7. 🛛 Examiner's Am	endment/Comment
4. Examiner's Comment Regarding Requirement for Deposit of Biological Material		tement of Reasons for Allowance
	9.  Other	
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**Notice of Allowability** 

## **EXAMINER'S AMENDMENT**

An examiner's amendment to the record appears below. Should the changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312. To ensure consideration of such an amendment, it MUST be submitted no later than the payment of the issue fee.

The application has been amended as follows:

<u>Title:</u> Pixel electrode with a second aperture formed directly above a first aperture of the upper electrode of the storage capacitor.

Authorization for this examiner's claim amendment below was given in a telephone interview with Belinda Lee on 1/8/2007.

Claim 1 and Claim 14 is amended to replace the word "when" to a "," (comma).

AMENDED Claim 1 (Page 3, Lines 1-3) "...wherein each of pixel electrodes further comprises at least a second aperture, the first aperture is located underneath the pixel electrode, and the second aperture is formed directly above the first aperture."

AMENDED Claim 14 (Page 5, lines 3-6) "... wherein each of pixel electrodes further comprises at least a second aperture, the first aperture is located underneath the pixel electrode, and the second aperture is formed directly above the first aperture.

## Claims 1-7,9-14 are allowed.

The following is an examiner's statement of reasons for allowance:

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Nishikawa discloses (Figure 5A,5B) wherein each of the pixel electrodes (55) further comprises at least a second aperture (shown above) when the first aperture (shown above) is located underneath the pixel electrode (55) and the second aperture is formed above the first aperture.

Nishikawa does not disclose the second aperture formed directly above the first aperture.

It would have not been obvious to combine another reference to disclose the second aperture of the pixel electrode being directly above the first aperture of the upper electrode of the storage capacitor.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Lucy P. Chien whose telephone number is 571-272-8579. The examiner can normally be reached on M-F 8:30-5:00.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, David Nelms can be reached on (571)272-1787. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

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Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would like assistance from a USPTO Customer Service Representative or access to the automated information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

Lucy P Chien Examiner Art Unit 2871

> Andrew Schechter PRIMARY EXAMINER